

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

NORTHRUP ET AL

Serial No.: 08/482,933

Filed: June 7, 1995

Title: MICROFABRICATED REACTOR



Group Art Unit: 1634

Examiner: Marschel

September 17, 1999

11/1  
11/1  
11/22/99  
(NT)

AMENDMENT

Honorable Commissioner of  
Patents and Trademarks  
Washington, D.C. 20231

Sir:

In response to the Office Action dated March 17, 1999, please amend  
the above application as follows:

IN THE CLAIMS

Amend claim 83 as follows:

83. (Thrice Amended) The process of claim 81 [a process for  
manufacturing on a wafer an instrument for controlling a chemical reaction,  
comprising the steps of etching said wafer to form a reaction chamber,]  
further comprising the step of [and] depositing [a resistive element on said  
wafer adjacent a boundary of said reaction chamber] depositing] a Lamb-wave  
transducer on said wafer.

09/21/1999 MBLAWCO 00000012 08482933

01 FC:217  
02 FC:219

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